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D.D. 9-18-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 09/837,645
Priority Filing Date April 17, 2001
Inventor Sandhu et al.
Assignee Micron Technology, Inc.
Priority Group Art Unit 2813
Priority Examiner Schillinger, L.
Attorney's Docket No. MI22-1780
Title: Methods of Forming a Thin Film Transistor

PRELIMINARY AMENDMENT

To: ~~BOX PATENT APPLICATION~~
Assistant Commissioner for Patents
Washington, D.C. 20231

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AMENDMENTS

In the Specification

At p. 1, before the "Technical Field" Section, insert

--RELATED PATENT DATA

This patent is a divisional application of U.S. Patent Application Serial No. 09/837,645 which was filed on April 17, 2001, which is a continuation of U.S. Patent No. 6,238,957, issued on May 29, 2001, which is a continuation of U.S. Patent No. 6,001,675, issued on December 14, 1999, which is a continuation of U.S. Patent No. 5,665,611, which was issued on September 9, 1997.--

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